



Docket No. 740756-2289

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Shunpei YAMAZAKI et al.) Group Art Unit: 1746
Serial No. 09/818,513) Examiner: Gentle E. Winter
Filed: March 28, 2001)
For: FILM-FORMING APPARATUS, METHOD OF) Date: February 11, 2003
CLEANING THE SAME, AND METHOD ...)

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SUPPLEMENTAL AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Supplemental to the Response to the Restriction Requirement filed February 10, 2003,
Applicants wish to further amend the application as follows:

IN THE CLAIMS:

Claims 16 and 17 are presented below in their amended form. The amendments to the
above-noted claims are outlined in an Attachment to the Amendment using the conventional
indication method of bracketing and underlining.

16. (Amended) A method of manufacturing an electro-optical device comprising:
irradiating a component provided in a film-forming chamber with at least one selected
from the group consisting of infrared light, UV-light, and visible light, thereby sublimating a
vapor deposition material adhering to the component; and
exhausting the sublimated vapor deposition material.

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02 FC:1201 84.00 OP